

Silicon processing

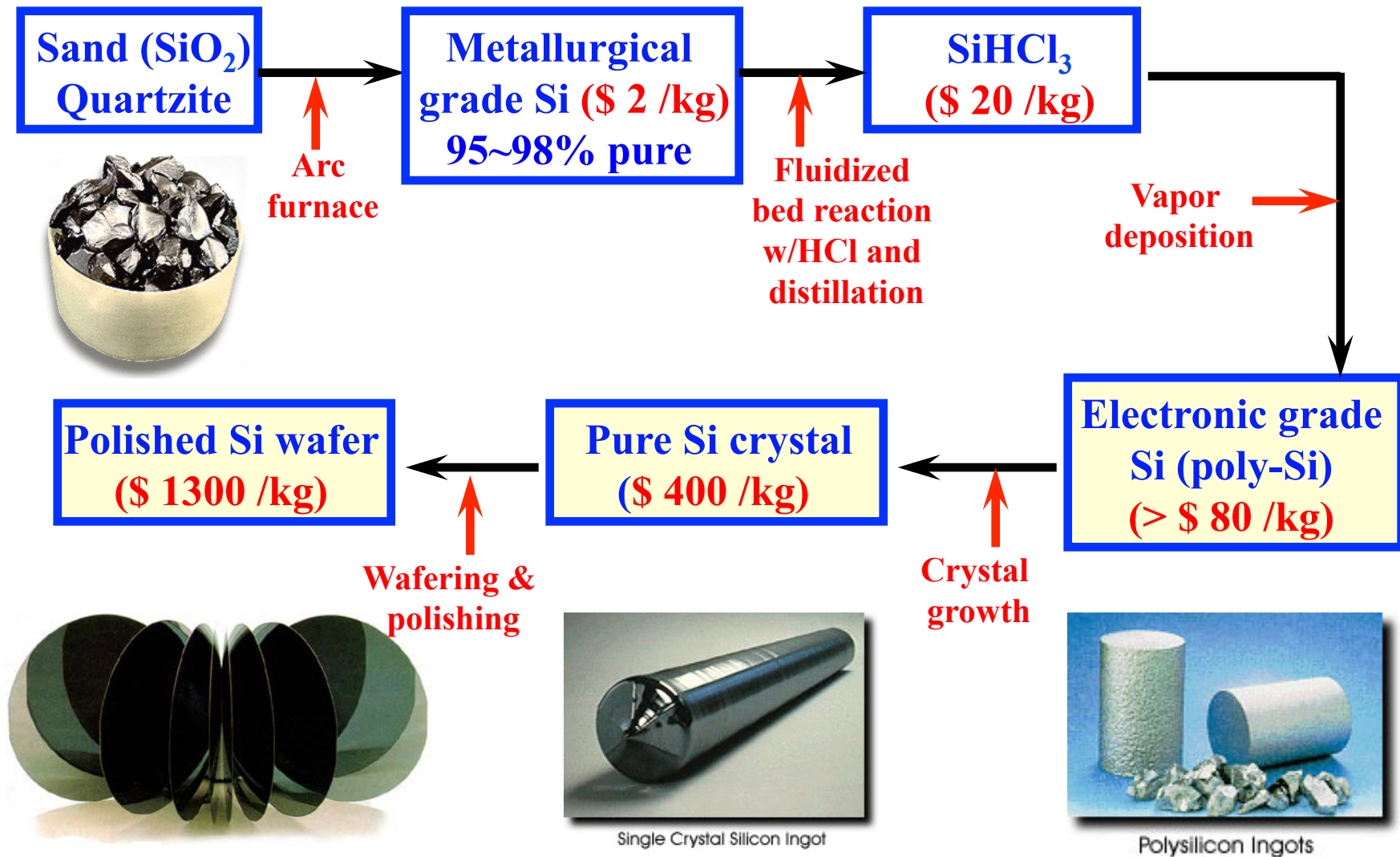
Metallurgical grade silicon

(Solar grade silicon)

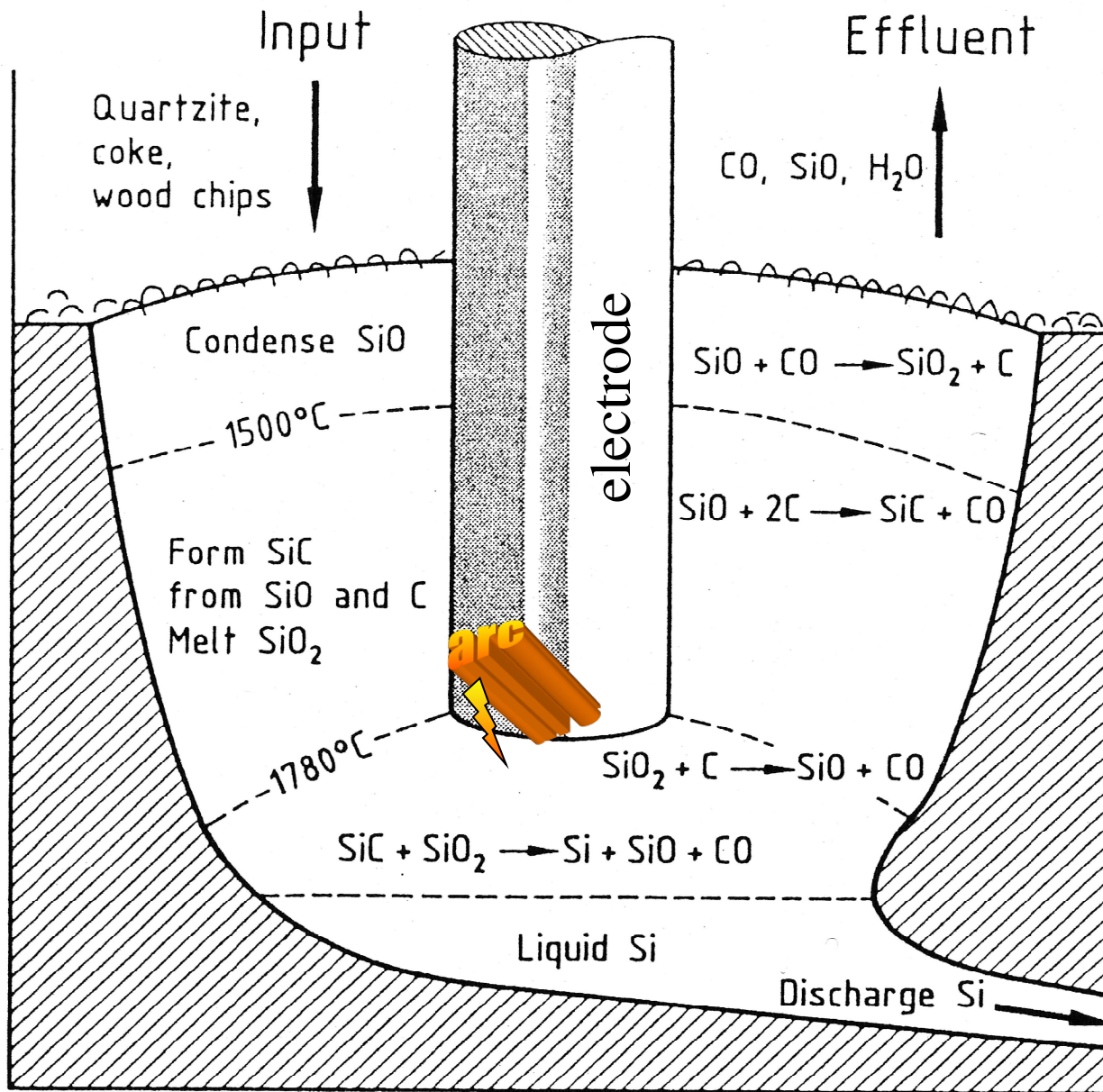
Electronic grade silicon

Wafers

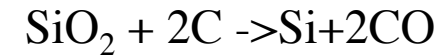
overview Sand to silicon wafer



Production of metallurgical grade Si



Overall reaction



Complicated in furnace

Charge porous or explosion



A world leader Si supplier
To steel -, Al alloy industry

Purification of MG Si -> Semicond. grade

Through Chlorsilane

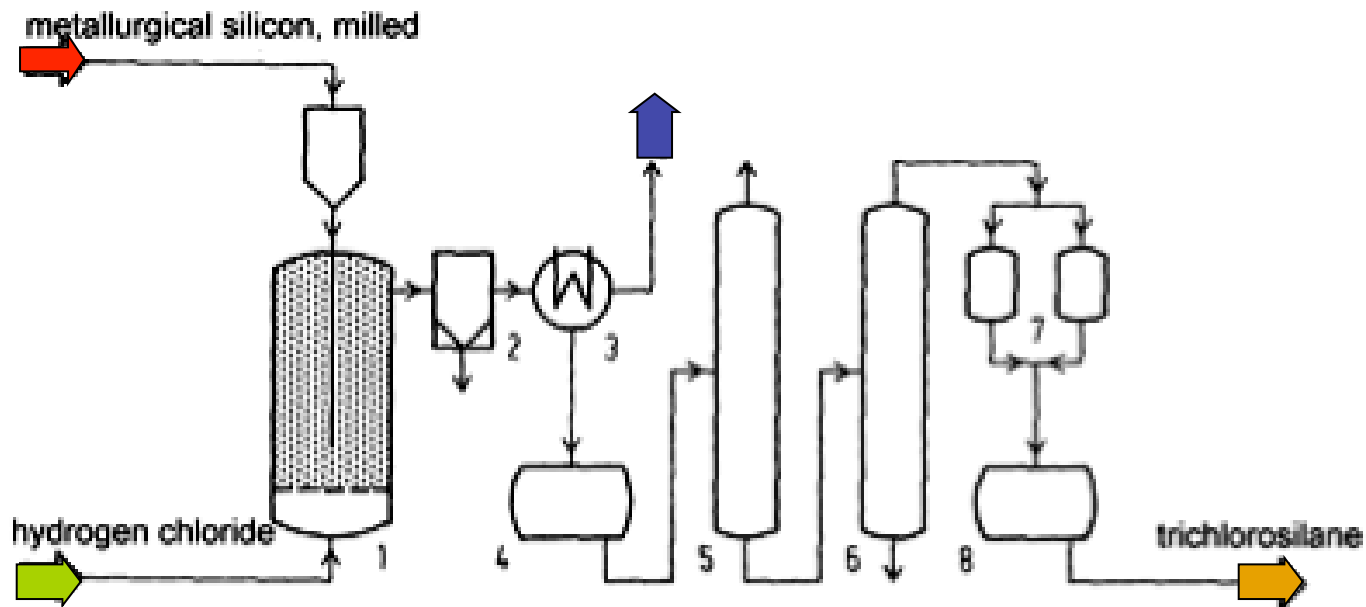
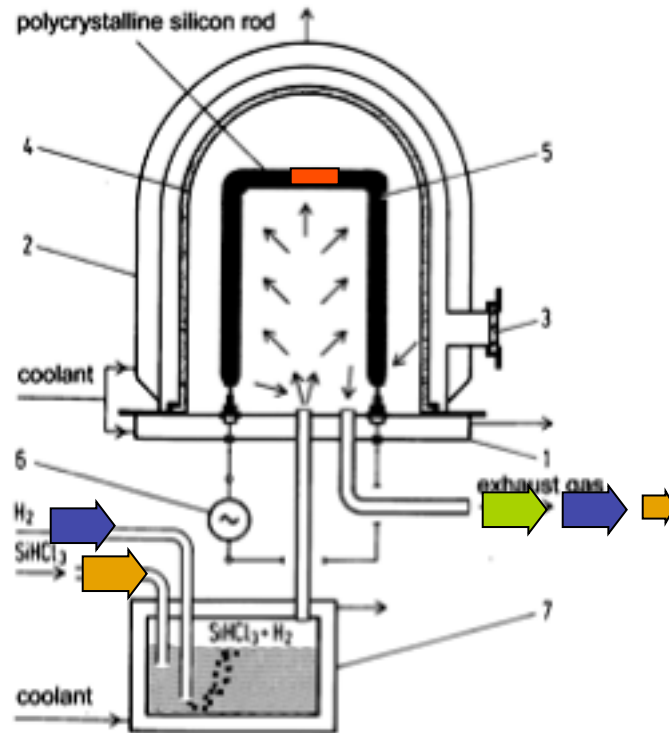


Fig. 3-1: Flow chart of a facility for production and purification of trichlorosilane. 1: fluidised bed reactor, 2: dust filter, 3: condenser, 4: collector, 5: column for cutoff of low boiling materials, 6: column for cutoff of high-boiling materials, 7: intermediate collectors, 8: storage tank



Purification of MG Si -> Semicond. grade

Chlorsilane to polyX Si
CVD(Siemens)



1950 Fig.

Only bigger in modern

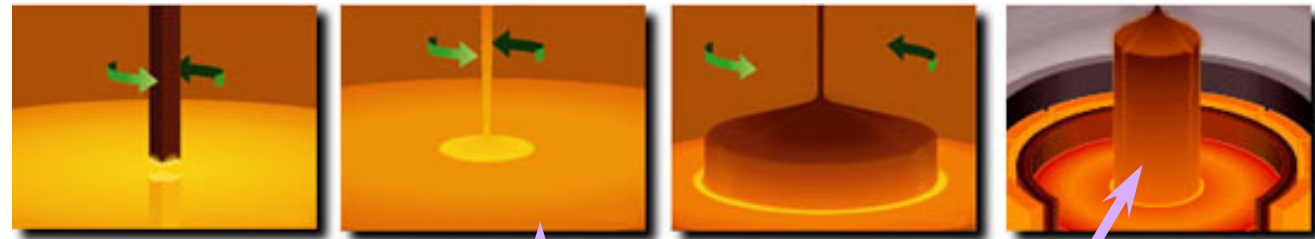
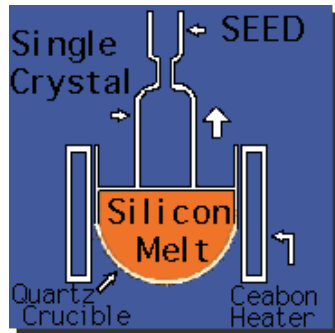
Fig. 3-2: Schematic drawing of a facility for silicon refinement from the gas phase (Siemens process). 1: cooled platform, 2: cooled protective glass, 3: viewing glass, 4: quartz bulb, 5: silicon core (thin rod), 8: current supply, 9: saturator

Today: Si 2-3 m length
900 °C,



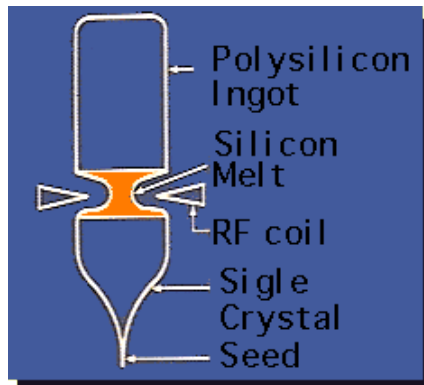
Growth of Electronic grade Si (xtal) from Semicond. Grade poly xtal Si

Czochralski (CZ) and float-zone (FZ) techniques

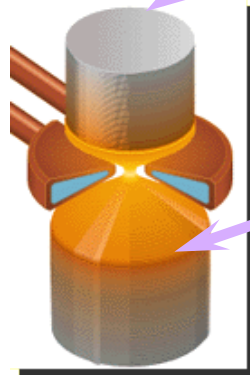


CZ

Poly-Si



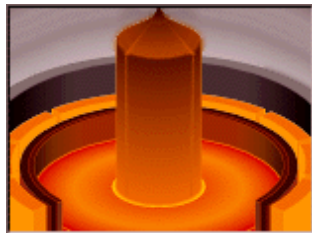
FZ



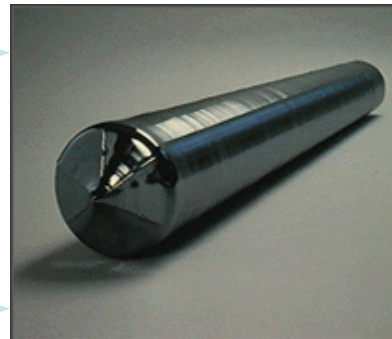
Single crystal Si

Sources: <http://www.fullman.com/semiconductors/semiconductors.html>
<http://www.msil.ab.psiweb.com/english/msilhist0-e.html>

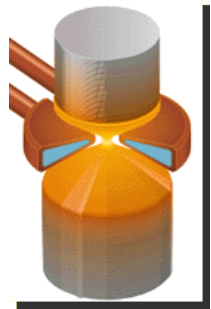
Ingots to wafer



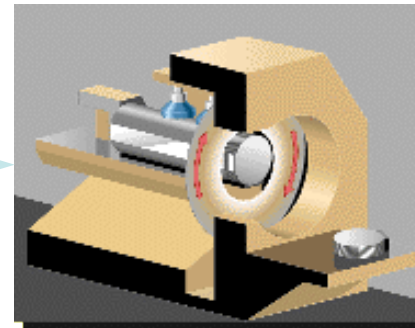
CZ



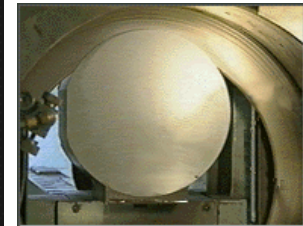
Ingots



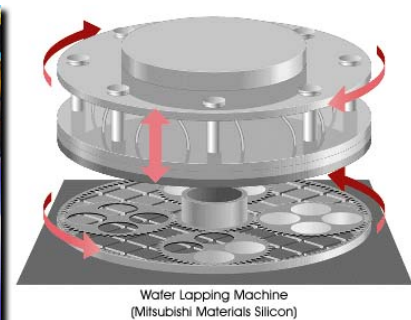
FZ



Slicing

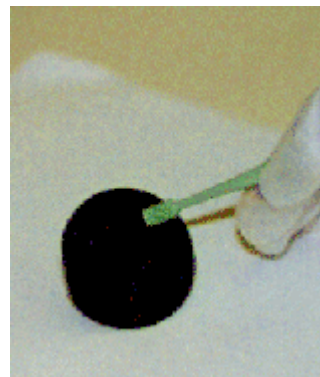


Polishing



Lapping

**Wafers for IC
manufacturing**



Sources: <http://www.fullman.com/semiconductors/semiconductors.html>
<http://www.msil.ab.psiweb.com/english/msilhist0-e.html>

increasing wafer size

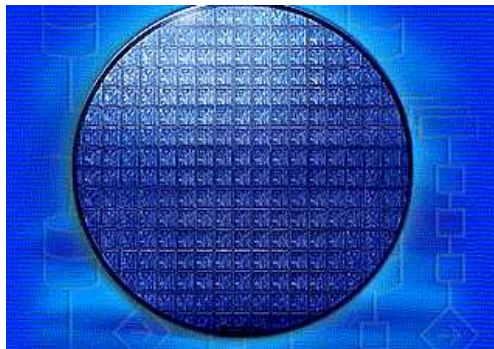


2" dia.

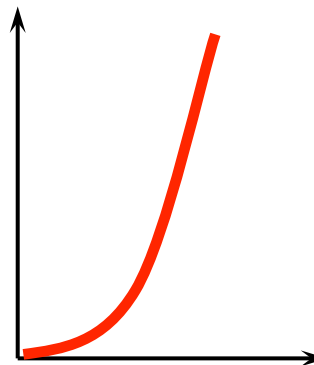


12" dia.

12" pizza

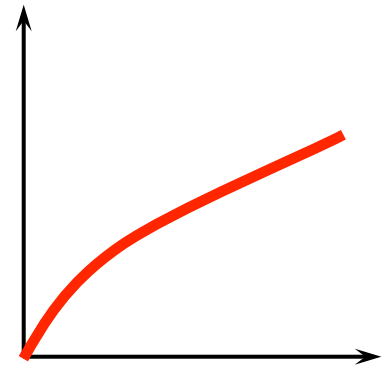


of dies



Wafer size

Production cost



Wafer size